
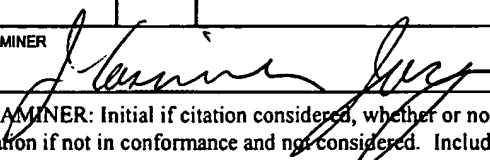


Subst. Form PTO-1449  <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  (Use several sheets if necessary)				Docket Number (Optional) 56231-433 (MKSK-134)		Application Number 10/814,973	
				Applicant <b>A. Shajii et al.</b>			
				Filing Date March 30, 2004		Group Art Unit	
<b>U. S. Patent Documents</b>							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
CJ	A	4,796,854	01/10/89	Ewing	251	129.07	05/18/87
<b>FOREIGN PATENT DOCUMENTS</b>							
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES      NO
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
CJ	B	© 2000 MKS Instruments, Inc., "Pressure-Based Mass-Flo® Controller For Ion Implant Applications Type 1640," Bulletin 1640 - 4/00.					
CJ	C	© 2000 MKS Instruments, Inc., "Metal-Sealed Mass-Flo® Controller Type 1479A," Bulletin 1479A-5/00.					
EXAMINER 				DATE CONSIDERED 6/21/05			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy with next communication to applicant.							

Subst. PTO-1449 (1-94)